

Inventor Information

Inventor One Given Name:: Masahiro
Family Name:: FURUSAWA
City of Residence:: Suwa-shi
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Two Given Name:: Satoru
Family Name:: MIYASHITA
City of Residence:: Suwa-shi
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Three Given Name:: Ichio
Family Name:: YUDASAKA
City of Residence:: Suwa-shi
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Four Given Name:: Tatsuya
Family Name:: SHIMODA
City of Residence:: Suwa-shi
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Five Given Name :: Yasuaki
Family Name:: YOKOYAMA
City of Residence:: Tokyo
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Six Given Name :: Yasuo
Family Name:: MATSUKI
City of Residence:: Tokyo
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Seven Given Name :: Yasumasa
Family Name:: TAKEUCHI
City of Residence:: Tokyo
Country of Residence:: Japan
Citizenship Country:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Title Line One:: A METHOD FOR FABRICATING A SILICON
Title Line Two:: THIN-FILM
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Prior Foreign Applications

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